

Substitute for Form 1449 A & B/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet 1 of 1

Complete Known 542546

Application Number	Based on PCT/GB2004/000161
Confirmation Number	Unknown
Filing Date	July 18, 2005
First Named Inventor	Henning SIRRINGHAUS
Art Unit	Unknown 2813
Examiner Name	Unknown Blum
Attorney Docket Number	Q89250

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ³ (if known)		
		US 2002/119584	A1	08-29-2002	Gregg Duthaler, et al.
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁴
		Country Code ²	Number ²	Kind Code ³ (if known)			
		WO	01/46987	A	06-28-2001	PLASTIC LOGIC LTD	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issu number(s), publisher, city, and/or country where published.	Translation ⁴
		KAWASE, T. et al., "All-Polymer Thin Film Transistors Fabricated by Inkjet Printing", Proceedings of the SPIE, SPIE, Bellingham, VA, US Vol. 4466, July 29, 2001, Pages 80-88, XP008006102, ISSN: 0277-786X	
		CHABINYC MICHAEL L, et al., "Organic Polymeric Thin-film Transistors Fabricated by Selective Dewatering", Applied Physics Letters, American Institute of Physics, New York, US, Vol. 81, No. 22, November 25, 2002, 4260-4262, XP012032662, ISSN: 0003-6951	
		ZHANG, J. et al., Investigation of Using Contact and Non-contact Printing Technologies For Organic Transistor Fabrication, Material Research Society Symposium Proceedings, Materials Research Society, Pittsburgh, PA, US, Vol. 725, April 1, 2002, Pages 155-160, XP008020720, ISSN: 0272-9172	
		PEDE, D., et al., Microfabrication of Conducting Polymer Devices by Ink-jet Stereolithography", Materials Science and Engineering C, Elsevier Science S.A, CH, Vol. C05, No. 3/4, February 1998, pages 289-291, XP000828177, ISSN: 0928-4931	

Examiner Signature	/David Blum/	Date Considered	12/15/2009
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /D.B./

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